

USSN 10/765,647

PATENT

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Signed: Linda A. Jimura Date: April 14, 2006

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Laura Wills Mirkarimi

Group Art Unit: 1765

Serial No.: 10/765,047

Examiner: Deo

Filed: January 26, 2004

For: METHOD FOR ETCHING HIGH ASPECT RATIO FEATURES IN III-V BASED
COMPOUNDS FOR OPTOELECTRONIC DEVICES

Attorney Docket No. 10030753-1

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In reply to the Final Office Action in the above identified application, Applicant
submits the following Amendments and Remarks.